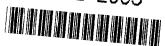
4-22-05

Form **PTO-1595** (Rev. 06/04) OMB No. 0651-0027 (exp. 6/30/2005)

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PATENT REEL: 016498 FRAME: 0900

	Docket Number (Optional)	
ASSIGNMENT OF APPLICATION	3372.2.5	
We, Guizhen Yan. Yong Zhu, Jie Fan, Xuesong Liu, Jian Zhou, and Yangvuan Wang whose residences and post office addresses are as stated below next to our names, hereafter referred to as applicants, have invented certain new and useful improvements in METHOD FOR FABRICATING HIGH ASPECT RATIO MEMS DEVICE WITH INTEGRATED CIRCUIT ON THE SAME SUBSTARATE USING POST-CMOS PROCESS		
for which an application for a United States Par	atent was filed on	
for which an application for a United States Parand	atent was executed on	
Whereas, Peking University a corporation of China haddress is Peking University, Beijing 100871 P.R. Chitile and interest in the same; Now, therefore, in consideration of the sum of gis acknowledged, and other good and valuable these presents do sell, assign and transfer untright to the said invention in the United States and to any and all Patents which may be granhereby authorize and request the Commissione said United States Patent to said assignee, of the to the same, for his sole use and benefit; and representatives, to the full end of the term for whand entirely as the same would have been held been made.	hina is desirous of acquiring the entire right, one dollars (\$1.00), the receipt whereof le consideration, We, the applicants, by ito said assignee the full and exclusive and the entire right, title and interest in inted therefor in the United States, We er of Patents and Trademarks to issue the entire right, title, and interest in and ind for the use and benefit of his legal hich said Patent may be granted, as fully	
Executed this 21 day of April , 2005,	at Beijing China	
	Guizhen Van Guizhen Van Institute of Microelectronics Peking University Beijing 100871 P.R. China	
Executed this <u>21</u> day of <u>April</u> , 2005,		

PATENT REEL: 016498 FRAME: 0901

Executed this 21 day of April , 2006, at Boijing Ch	ika
Jie Fan Institute of Microelectro Peking University Beijing 100871 P.R. China	onics .
Executed this 21 day of April , 2005, at Beijing	China.
Xuesong Liu Institute of Microelectro Peking University Beijing 100871, P.R. China	
Executed this 2/day of April , 2005, at Beijing C	china_
Jian Zhou Jian Zhou Institute of Microelectr Peking University Beijing 100871 P.R. China	,
Executed this 2/ day of Apri/, 2005, at Beijing	China
Yangyuan Wang Institute of Microelectr Peking University Beijing 100871	onics

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